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Application serial No. 10/710,542
Examiner: NELSON, VIVIAN HSU
Art Unit: 2851

MAR 13 2006

First Inventor: Ming-Chien Chiu

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Application No.: 10/710,542

Filed: July 20, 2004

For: Photomask Positioning Apparatus

Applicant: Ming-Chien Chiu

Examiner: Nelson, Vivian Hsu

Art Unit 2851

**CERTIFICATE OF FACSIMILE AND
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Signature

Ming-Chien Chiu

RESPONSE TO NON-FINAL OFFICE ACTION

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Dear Sir:

In response to the office action mailed December 20, 2005, please enter the following amendments and consider the following remarks.